

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4552	(nitridation or nitridi\$5 or nitridi?ation or nitrification or nitrif\$5 or nitrat\$3 or nitration) near3 (silicon or poly-silicon or polysilicon or (poly adj (silicon or Si)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:09
L2	98777	partial\$3 near3 pressure\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:09
L3	176872	gate near3 (oxide\$1 or dioxide or dielectric\$1 or insulat\$3 or isolat\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:10
L4	69512	(CVD or \$5CVD or (chemical adj (vapor or vapour) adj deposit\$5)) near15 (silicon or poly-silicon or polysilicon or (poly adj (silicon or Si)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:54
L5	359	4 same 2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:13
L6	4	5 same 1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:15
L7	23	5 and 1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:15
L8	297	(RT-CVD or RT-CVD or (((rapid adj thermal) or RT) adj ((chemical adj (vapor or vapour) adj deposit\$5) or CVD))) near15 (silicon or poly-silicon or polysilicon or (poly adj (silicon or Si)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:59

L9	6	8 same 2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:58
L10	6	2 same (RT-CVD or RT-CVD or (((rapid adj thermal) or RT) adj ((chemical adj (vapor or vapour) adj deposit\$5) or CVD))) same (silicon or poly-silicon or polysilicon or (poly adj (silicon or Si)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 12:15
S1	4	((("5563093") or ("6005807") or ("6087229") or ("6323114")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:12
S2	1	("6596595").PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:14
S3	7	((("6410968") or ("6475883") or ("20010014522") or ("6291868") or ("20020025658") or ("6362086") or ("20020060348")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:14
S4	6	((("5634974") or ("5759262") or ("6127287") or ("6204206") or ("6228779") or ("6245689")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:17
S5	4246	((silicon near2 contain\$4) or silicon-contain\$4) near3 gas\$2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 14:53
S6	93486	partial\$3 near3 pressure\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:09
S7	39	S5 with S6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 14:55
S8	16926	((nitrogen near2 contain\$4) or nitrogen-contain\$4) near3 gas\$2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 14:56

S9	406426	(silicon adj nitride) or SiN or "SiN" or Si3N4 or "Si3N4" or "Si.sub.3N.sub.4" or "Si.sub.3 N.sub.4"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 15:10
S10	504	S8 with S9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 14:58
S11	3	S7 and S10	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 14:58
S12	16	S9 and S7	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 15:10
S13	3	((("5138401") or ("6203613") or ("6531364")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 10:55
S14	3	((("6544908") or ("6559007") or ("6815805")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 11:16
S15	4	((("5563093") or ("6005807") or ("6087229") or ("6323114")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:12
S16	1	("6596595").PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:14
S17	7	((("6410968") or ("6475883") or ("20010014522") or ("6291868") or ("20020025658") or ("6362086") or ("20020060348")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:16
S18	6	((("5634974") or ("5759262") or ("6127287") or ("6204206") or ("6228779") or ("6245689")).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 12:19
S19	24	S13 or S14 or S15 or S16 or S17 or S18	US-PGPUB; USPAT	OR	OFF	2005/11/12 14:45
S20	1	("6087229").PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 14:45
S21	34	("6087229").URPN.	USPAT	OR	OFF	2005/11/12 14:46
S22	34	"6033998"	USPAT	OR	OFF	2005/11/12 14:46
S23	1	("6033998").PN.	US-PGPUB; USPAT	OR	OFF	2005/11/12 14:46

S24	11	("4621277" "4913929" "5258333" "5422291" "5464783" "5834351" "5837598" "5888870" "5904523" "5960289" "5969397").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/11/12 15:31
S25	4551	(nitridation or nitridi\$5 or nitridi?ation or nitrification or nitrif\$5 or nitrat\$3 or nitration) near3 (silicon or poly-silicon or polysilicon or (poly adj (silicon or Si)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:09
S26	98764	partial\$3 near3 pressure\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/12 15:43
S27	327	S25 and S26	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/12 15:43
S28	176771	gate near3 (oxide\$1 or dioxide or dielectric\$1 or insulat\$3 or isolat\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/13 10:10
S29	172	S27 and S28	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/11/12 15:44